



1FCW

Docket No. 2003-0744 / 24061.123
Customer No. 42717

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Hui-Jye Hshieh, et al.

§ Docket No.: 2003-0744 / 24061.123

Serial No.: 10/822,522

§ Examiner: To Be Determined

Filed: April 12, 2004

§ Art Unit: To Be Determined

For: Method and System for Communicating
Semiconductor Manufacturing
Information to Customers

§ Conf. No.: 3356

§

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendments
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited patents are listed in numerical order and are not in any order based on their pertinence.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)).

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,

David M. O'Dell
Registration No. 42,044

Date: 10-11-04

HAYNES AND BOONE, LLP
901 Main Street, Suite 3100
Dallas, Texas 75202-3789
Telephone: 972-739-8635
Facsimile: 214-200-0853

Certificate of Mailing

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to M/S Amendment, Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Bonnie Boyle
Name

10-11-04



<p>In place of PTO-1449 Form</p> <p style="text-align: center;">INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)</p>	<p style="text-align: center;">U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE</p>	<p style="text-align: center;"><i>Complete if Known</i></p> <table border="1" style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 40%;">Application Number</td> <td>10/822,522</td> </tr> <tr> <td>Filing Date</td> <td>April 12, 2004</td> </tr> <tr> <td>Applicant(s)</td> <td>Hui-Jye Hsieh, et al.</td> </tr> <tr> <td>Art Unit</td> <td>2816</td> </tr> <tr> <td>Examiner Name</td> <td>To Be Determined</td> </tr> <tr> <td colspan="2">Attorney Docket Number</td> </tr> </table>			Application Number	10/822,522	Filing Date	April 12, 2004	Applicant(s)	Hui-Jye Hsieh, et al.	Art Unit	2816	Examiner Name	To Be Determined	Attorney Docket Number	
Application Number	10/822,522															
Filing Date	April 12, 2004															
Applicant(s)	Hui-Jye Hsieh, et al.															
Art Unit	2816															
Examiner Name	To Be Determined															
Attorney Docket Number																
SHEET	1	OF	1	2003-0744 / 24061.123												

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner's Initials	Cite No.	Foreign Patent Document (Country Code - Number - Kind)	Publication Date MM-DD-YYYY	Patentee or Applicant of Cited Document	Translation Y-N

OTHER PRIOR ART

Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city-country where published
	AA	HSIEH, DENNYS SUNG-TING, et al., "TSMC Turnkey Data Mart", SMTW 2002 Symposium, http://dennys.tiger2.net/me/publication/2002.12.10_smtw/index.html , printed on January 9, 2004, 5 pages.
	AB	HSEIH, DENNYS SUNG-TING, et al., "B2B in TSMC Turnkey Service", ISSM 2001 Symposium, http://dennys.tiger2.net/me/publication/2001.10.08_issm/index.html , printed on January 9, 2004, 5 pages.

Examiner Signature		Date Considered	
-----------------------	--	--------------------	--

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.